



NEW ATTORNEY DOCKET NO.: 052640-5031-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Namwoong PAIK et al. ) Confirmation No. 5216  
Application No.: 10/695,485 ) Group Art Unit: 1753  
Filed: October 29, 2003 ) Examiner: Unassigned  
For: METHOD OF FORMING NON-OXIDE )  
THIN FILMS USING NEGATIVE )  
SPUTTER ION BEAM SOURCE )

Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
**Customer Window, MS Non-Fee Amendment**  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

**SUPPLEMENTAL PRELIMINARY AMENDMENT**

Prior to the examination on the merits of the above-identified application, please amend  
the above-identified application as follows: